



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

November 12, 2024

IGI Report Number

LG660445341

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

ROUND BRILLIANT

Measurements

8.42 - 8.46 X 5.28 MM

GRADING RESULTS

Carat Weight

2.35 CARATS

Color Grade

F

Clarity Grade

VVS 2

Cut Grade

IDEAL

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

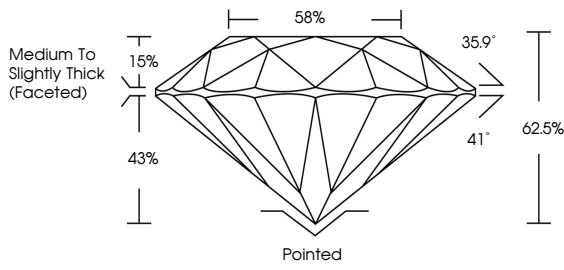
NONE

Inscription(s)

 LG660445341

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Medium To Slightly Thick (Faceted)

58%

35.9°

41°

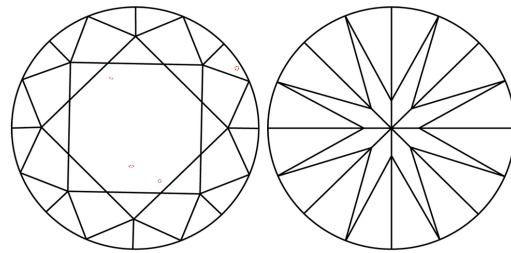
62.5%

43%

15%

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

IF

VS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included

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F

Carat Weight

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Color Grade

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Clarity Grade

VVS 2

Depth

62.5%

Table

58%

Girdle

Medium To Slightly Thick (Faceted)

Culet

Pointed

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EXCELLENT

Symmetry

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Fluorescence

NONE

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